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**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In Re application of

**Oh-Nam KWON**

Application No.: 09/709,483

Filed: November 13, 2000

For: **METHOD OF MANUFACTURING A THIN FILM TRANSISTOR**

Group Art Unit: 2823

Examiner: T. Pham

*do not enter in P&T*  
Commissioner of Patents  
Washington, D.C. 20231

Dear Sir:

In response to the Examiner's Final Office Action dated April 18, 2002, the following amendments and remarks are respectfully submitted.

**IN THE DRAWINGS:**

Please amend the drawings as shown in red in the attached Request for Examiner's Approval of Drawing Changes.

**IN THE SPECIFICATION:**

Please amend the specification as follows (A Marked-Up Version of the Amended Specification is attached):

On page 2, Paragraph beginning on line 13:

Fig. 1 is a cross sectional view illustrating a typical AM-LCD device. As shown in Fig. 1, the LCD device 20 includes lower and upper substrates 1 and 3, with a liquid crystal

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